

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:)	Confirmation No.: 3788
Shinji MAEKAWA et al.)	
Application No. 10/575,492)	Examiner: Stanetta D. Isaac
Filed: April 12, 2006)	Group Art Unit: 2812
For: METHOD FOR FORMING WIRING, METHOD)	
FOR MANUFACTURING THIN FILM)	
TRANSISTOR AND DROPLET DISCHARGING)	
METHOD)	

AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the non-final Office Action mailed March 10, 2009, please amend the above-captioned application, as follows:

Amendments to the Claims are reflected in the listing of claims in the paper.

Remarks follow the amendment section of this paper.